

## United States Patent and Trademark Office

in

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/622,871	07/17/2003	Masahiro Murasato	791_203 NP	2911	
25191	7590 02/04/2005		EXAM	EXAMINER	
BURR & BROWN			DOUGHERTY, THOMAS M		
PO BOX 7068 SYRACUSE, NY 13261-7068			ART UNIT	PAPER NUMBER	
			2834	<del></del>	
			DATE MAILED: 02/04/2009	DATE MAILED: 02/04/2005	

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)			
		10/622,871	MURASATO ET AL.			
	Office Action Summary	Examiner	Art Unit			
		Thomas M. Dougherty	2834			
	The MAILING DATE of this communication	appears on the cover sheet with the c	correspondence address			
THE I - Exter after - If the	ORTENED STATUTORY PERIOD FOR REMAILING DATE OF THIS COMMUNICATIOnsions of time may be available under the provisions of 37 CFR SIX (6) MONTHS from the mailing date of this communication, period for reply specified above is less than thirty (30) days, a	N. 1.136(a). In no event, however, may a reply be ting reply within the statutory minimum of thirty (30) day	nely filed rs will be considered timely.			
- If NO - Failu Any r	period for reply is specified above, the maximum statutory per re to reply within the set or extended period for reply will, by sta reply received by the Office later than three months after the ma ed patent term adjustment. See 37 CFR 1.704(b).	iod will apply and will expire SIX (6) MONTHS from Itute, cause the application to become ABANDONE	the mailing date of this communication.  (D) (35 U.S.C. § 133).			
Status						
1)⊠	Responsive to communication(s) filed on 2/	1/05 (phone interview).				
		his action is non-final.				
3)						
	closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.					
Dispositi	on of Claims					
4)🖂	Claim(s) 1 and 2 is/are pending in the applic	cation.				
	4a) Of the above claim(s) is/are withdrawn from consideration.					
5)	Claim(s) is/are allowed.					
6)⊠	☐ Claim(s) <u>1 and 2</u> is/are rejected.					
7)	Claim(s) is/are objected to.					
8)□	Claim(s) are subject to restriction and	d/or election requirement.				
Applicati	on Papers					
9)□ .	The specification is objected to by the Exam	iner.				
,	10)⊠ The drawing(s) filed on 17 July 2003 is/are: a)⊠ accepted or b)□ objected to by the Examiner.					
	Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).					
	Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).					
11) 🔲	The oath or declaration is objected to by the	Examiner. Note the attached Office	Action or form PTO-152.			
Priority u	ınder 35 U.S.C. § 119					
12)🛛	Acknowledgment is made of a claim for fore	ign priority under 35 U.S.C. § 119(a)	)-(d) or (f).			
a)[	⊠ All b) Some * c) None of:					
	1. Certified copies of the priority docume	ents have been received.				
	2. Certified copies of the priority docume	ents have been received in Applicati	on No			
	3. Copies of the certified copies of the p	riority documents have been receive	ed in this National Stage			
	application from the International Bure	, ,,,				
* S	see the attached detailed Office action for a l	ist of the certified copies not receive	ed.			
Attachment		Λ M (max + 1 = 0	(DTO 442)			
	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-948)	4) 🔀 Interview Summary Paper No(s)/Mail Da				
3) 🔲 Inforn	nation Disclosure Statement(s) (PTO-1449 or PTO/SB/r No(s)/Mail Date	08) 5) Notice of Informal P 6) Other:	atent Application (PTO-152)			

Application/Control Number: 10/622,871

Art Unit: 2834

## **DETAILED ACTION**

Claim Rejections - 35 USC § 103The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1 and 2 are rejected under 35 U.S.C. 103(a) as being unpatentable over Takeuchi et al. (US 6,396,196) in view of Funemi et al. (JP 2000-261283). Takeuchi et al. show (fig. 3) a piezoelectric/electrostrictive film type (1) device comprising: a substrate formed of a ceramic (see ABSTRACT), and a piezoelectric/electrostrictive operation portion (5) in which at least one piezoelectric/electrostrictive layer (5) and at least one pair of electrodes (4, 6) electrically connected to the piezoelectric/electrostrictive layer (5) are stacked on the substrate (2).

Takeuchi et al. do not note that their device includes a highly water repellent surface formed on at least one of outer surface of the piezoelectric/electrostrictive layer and an upper electrode of said at least one pair of electrodes.

Funemi et al. show (fig. 1) a piezoelectric/electrostrictive film type (1) device comprising: a piezoelectric/electrostrictive operation portion (5) in which at least one piezoelectric/electrostrictive layer (5) and at least one electrode (3) electrically connected to the piezoelectric/electrostrictive layer (5).

Application/Control Number: 10/622,871

Art Unit: 2834

Funemi et al. further show a highly water repellent surface (2) that is formed on at least one of outer surface of the piezoelectric/electrostrictive layer (5) and an upper electrode (3).

Said highly water repellent surface (2) is modified in such an extent that infiltration of moisture into micro-pores opened in at least one of the outer surface of the piezoelectric/electrostrictive layer (5) and the upper electrode (3), and/or into a gap between the substrate and the piezoelectric/electrostrictive layer (5) is sufficiently inhibited.

Funemi et al. do not show at least two electrodes in a stack configuration with their piezoelectric/electrostrictive substrate. It is unknown whether or not their substrate is a ceramic material specifically.

It would have been obvious to one having ordinary skill in the art to employ the highly water repellent surface of Funemi et al., which is modified so that infiltration of moisture into micro-pores opened in the outer surface of the piezoelectric/electrostrictive layer or into gaps between the substrate and the piezoelectric/electrostrictive layer is sufficiently inhibited, forming it on the outer surface of at least the piezoelectric/electrostrictive layer or the upper electrode, in the device of Takeuchi et al. in order to provide a device superior in resistance to stresses caused by use and weather, as noted by Funemi et al. Such a design would lengthen the lifetime of the device, thereby reducing replacement costs.

Art Unit: 2834

Direct inquiry to Examiner Dougherty at (571) 272-2022.

And tmd

February 1, 2005

TOM DOUGHERTY PRIMARY EXAMINER

Thomas M. Lougher

Page 4